

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attn: Office of Petitions
Madison West Bldg.In re the Application of
Takashi IGARASHI et al.

Application No.: 10/611,918

Filed: July 3, 2003

For: LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS
MEASUREMENT METHOD

Confirmation No.: 5605

Allowed: 11/1/06

Group Art Unit: 3723

Examiner: H. SHAKERI OFFICE OF PETITIONS

Docket No.: 108833.01

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FEB 06 2007

**PETITION FOR WITHDRAWAL FROM ISSUE AFTER
PAYMENT OF ISSUE FEE UNDER 37 CFR 1.313(c)(2)**Mail Stop 313(c)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants hereby petition that the above-identified application, in which the Issue Fee has been paid, be withdrawn from issue pursuant to 37 CFR 1.313(c)(2). Withdrawal from issue is necessary to permit consideration of the attached Request for Continued Examination and Information Disclosure Statement.

Please charge any fees or credit any overpayment of fees to Deposit Account No. 15-0461.

Should there be any questions concerning this matter, please contact Applicants' undersigned attorney at the telephone number listed below.

Respectfully submitted,

*Leana Levin*James A. Oliff
Registration No. 27,075Leana Levin
Registration No. 51,939

JAO:LL/can

Attachments:
Request for Continued Examination
Information Disclosure StatementDate: February 6, 2007
OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
Charge any fee due to our
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02/06/2007 CKHLOK 00000018 150461 10611918

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OLIFF & BERRIDGE, PLC

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February 6, 2007

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FACSIMILE TRANSMISSION COVER SHEET**

FEB 06 2007

OFFICE OF PETITIONS

To: In re the Application of Takashi IGARASHI et al. Application No.: 10/611,918 Filed: July 3, 2003 For: LENS MACHINING APPARATUS, LENS MACHINING METHOD, AND LENS MEASUREMENT METHOD	FOR FILING IN THE U.S. PATENT AND TRADEMARK OFFICE Group Art Unit: 3723 Docket No.: 108833.01 Examiner: H. SHAKERI
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OFFICE OF PETITIONS

Facsimile: (571) 273-0025

From: Leana Levin
Reg No. 51,939**Prepared By:** Can**Number of Pages Sent (Including cover sheet):****Comments:**

Attached is a Petition for Withdrawal from Issue together with a Request for Continued Examination and Information Disclosure Statement for the above-identified application.

The following papers are attached:

- a. Petition for Withdrawal from Issue (1 page)
- b. Request for Continued Examination (1 page)
- c. Information Disclosure Statement (42 pages)

The U.S. Patent and Trademark Office is authorized to debit Deposit Account No. 15-0461 for any fees associated with this response.

Sent by: _____

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